



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 10/632,579  
Filing Date ..... July 31, 2003  
Inventor ..... J. Mattson  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2818  
Examiner ..... L. K. Tran  
Attorney's Docket No. .... MI22-2376  
Title: Methods Of Forming Magnetoresistive Memory Devices

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

To: Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

From: David G. Latwesen, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)  
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Dear Sir:

The attached form PTO-1449 is submitted in compliance with 37 CFR § 1.56. Copies of the cited art are included with the exception of U.S. patents and published U.S. applications (1276 Off. Gaz. Pat. Off. 55, 05 August 2003). No admission is made regarding whether all the submitted references are prior art.

A check in the amount of \$180.00 is enclosed to cover the fee specified under 37 C.F.R. § 1.17(p).

Dated: 1/14/04

Respectfully submitted,

By: [Signature]  
David G. Latwesen, Ph.D.  
Reg. No. 38,533

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Form PTO-1449

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.  
MI22-2376SERIAL NO.  
10/632,579LIST OF ART CITED BY APPLICANT  
(Use several sheets if necessary)APPLICANT  
J. MattsonFILING DATE  
July 31, 2003GROUP  
2818

## U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	5,998,016	12-1999	Sasaki et al.			
	AB	US2002/0186582 A1	12-2002	Sharma et al.			
	AC	US2003/0146459 A1	08-2003	Katti et al.			
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						

## FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AM							
	AN							
	AO							
	AP							
	AQ							

## OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

	AR		
	AS		
	AT		

EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.